

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Takeshi HIKATA

Title: METHOD OF PRODUCING
CARBON NANOSTRUCTURE

Appl. No.: 10/591,740

International 5/19/2005

Filing Date:

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Examiner: Roberts P. Culbert

Art Unit: 1792

Confirmation 3133

Number:

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated March 31, 2009, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 6 of this document.

Please amend the application as follows: